



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant

Kim et al.

Appl. No.

10/699,226

Filed

: October 31, 2003

For

PLASMA ENHANCED ALD OF

TANTALUM NITRIDE AND

BILAYER

Examiner

Turner, Archene A.

Group Art Unit

1775

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

June 9, 2005

James B. Bear, Reg. No 25,221

TRANSMITTAL LETTER

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application are:

- (X) Statement Regarding Third-Party Submission in Accordance with 37 C.F.R. §1.99.
- (X) Certificate of Service.
- (X) Form PTO/SB/08 listing four (4) references.
- (X) Full copies of each of the four (4) references listed on form PTO/SB/08.
- (X) A check in the amount of \$180.00, see 37 CFR § 1.17(p), to cover the submission fee.
- (X) Return prepaid postcard.

James B. Bear

Registration No. 25,221

Attorney of Record

Customer No. 20,995

(949) 760-0404



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P.O. Box 1450

Alexandria, VA 22313-1450

CERTIFICATION OF SERVICE IN ACCORDANCE WITH 37 C.F.R. § 1.248(b) (PROOF OF SERVICE)

Dear Sir:

I certify that the following enclosed documents were served upon David Aker, attorney for the above named applicant in the above-named matter:

- (X) Transmittal letter.
- (X) Statement regarding third-party submission in accordance with 37 C.F.R. § 1.99.
- (X) Form PTO/SB/08 listing four (4) references.
- (X) Full copies of the four references listed on form PTO/SB/08.

The documents were served in accordance with 37 C.F.R. § 1.248(a)(4) by mailing them on June \$6, 2005 via first class mail addressed to:

David Aker

23 Southern Road

Hartsdale, NY 10530

Dated:

69/05

Signed:

James B. Bear

Registration No. 25,221

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Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

STATEMENT REGARDING THIRD-PARTY SUBMISSION IN

ACCORDANCE WITH 37 C.F.R. § 1.99

Dear Sir:

This submission is a third-party submission of patents and publications in the above-named pending published application in accordance with 37 C.F.R. § 1.99. Enclosed is the fee set forth in 37 C.F.R. § 1.17(p) for this submission. This submission is being made within two months of publication of the above-named application. A certification of service is enclosed as required by 37 C.F.R. § 1.248(b).

Enclosed is form PTO/SB/08 listing four (4) references. Full copies of the four references listed on form PTO/SB/08 are also included.

The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment, to Account No. 11-1410.

06/13/2005 ZJUHAR1 00000049 10699226

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180.00 DP

Respectfully submitted,

Dated:

 $(O(1)^{1/2})$

By:

James B. Bear

Registration No. 25,221

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FATEMENT	BY ⁻	THIRD-PA	ARTY

Application No. 10/699,226

Filing Date October 31, 2003

First Named Inventor Kim

Art Unit 1775

Examiner Turner, Archene A.

Attorney Docket No.

(Mariple sheets used when necessary)

1 1 3 2005 🙀 SHEET 1 OF 1

U.S. PATENT DOCUMENTS					
xanimer Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
		2004/0009307 A1	01-15-2004	Koh et al.	
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	FOREIGN PATENT DOCUMENTS					
Examiner Initials	Cite No.	Foreign Patent Document Country Code-Number-Kind Code Example: JP 1234567 A1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	T ¹
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	NON PATENT LITERATURE DOCUMENTS				
Examiner Initials	Cite No.	itom (hook magazina journal sorial symposium astalas etc.) data paga(a) valuma jasus			
		Atomic Layer Deposition (ALD) 2002 American Vacuum Society Topical Conference, August 19-21, 2002, Hanyang University, Korea, Program Schedule and Content.			
		H. KIM & S.M. ROSSNAGEL, "The Growth and Properties of PE-ALD Ta and TaN Thin Films" (Invited lecture), Atomic Layer Deposition (ALD) 2002 American Vacuum Society Topical Conference, August 19-21, 2002, Hanyang University, Korea, Abstract.			
		H. KIM & S.M. ROSSNAGEL, "The Growth and Properties of PE-ALD Ta and TaN Thin Films" (Invited lecture), Atomic Layer Deposition (ALD) 2002 American Vacuum Society Topical Conference, August 19-21, 2002, Hanyang University, Korea, Presentation Slided.			

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Examiner Signature

Date Considered

*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.